

Notice of References Cited	Application/Control No. 10/565,517		Applicant(s)/Patent Under Reexamination KUMAZAWA, ITSUO	
	Examiner LILIANA CERULLO		Art Unit 4163	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,313,230	05-1994	Venolia et al.	345/163
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP 11353091 A	12-1999	Japan	KUMAZAWA, ITSUO	G06F 3/02
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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